



1774

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Appln. Of: ANDRE et al.

Serial No.: 09/830,380

Filed: April 25, 2001

For: THIN LAYER OF HAFNIUM OXIDE AND DEPOSIT PROCESS

Group: 1774

Examiner: T. Dicus

DOCKET: BREV 13186

Assistant Commissioner of Patents and Trademarks
Washington, D.C. 20231

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AMENDMENT B

Dear Sir:

This amendment is being filed in response to the Official Action mailed October 4, 2002.

Please amend the application as follows:

IN THE SPECIFICATION:

Please replace the sub-paragraph beginning on page 14, line 15, with the following
rewritten paragraph:

-- - Figure 3 between a layer of hafnium oxide comprising crystals of hafnium oxide
resulting from ion bombardment of the substrate and an amorphous layer according to the
invention.--

Please replace the sub-paragraph beginning on page 14, line 23, with the following
rewritten paragraph:

-- - Figure 5 is a curve representing the reflection of a mirror component of Figure 4 in
function of wavelength.--

Please replace the paragraph beginning on page 15, line 15, with the following rewritten
paragraph:

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